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Atty Docket: ZIMR/0018

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In accordance with 37 CFR § 1.97, this Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.

Respectfully submitted,



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|                        |                |
|------------------------|----------------|
| Application Number     | To be assigned |
| Filing Date            | 10/15/39179    |
| First Named Inventor   | Jürgen FROSIEN |
| Art Unit               | Unknown        |
| Examiner Name          | Unknown        |
| Attorney Docket Number | ZIMR/0018      |

[illegible][illegible]Date  
Considered

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# **INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Sheet 2 of 2

Complete if Known

Application Number 10/539179  
 Filing Date Herewith  
 First Named Inventor Jürgen FROSIEN  
 Art Unit Unknown  
 Examiner Name Unknown  
 Attorney Docket Number ZIMR/0018

## **NON PATENT LITERATURE DOCUMENTS**

| Examiner<br>Initials * | Cite<br>No. <sup>1</sup> | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.                                                                                     | T <sup>2</sup> |
|------------------------|--------------------------|-----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|----------------|
|                        |                          | HARAGUCHI, T., et al., "Development of Electromagnetic Lenses for Multielectron Beam Lithography System," <i>Journal of Vacuum Science &amp; Technology B</i> , (Microelectronics and Nanometer Structures), Nov. 2002, AIP for American Vacuum Soc., USA, Vol. 20, No. 6, Nov. 2002, pp. 2726-29, XP002251379, ISSN: 0734-211X, the whole document |                |
|                        |                          | Patent Abstracts of Japan, Vol. 2002, No. 09, September 4, 2002                                                                                                                                                                                                                                                                                     |                |
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|-----------------------|--|--------------------|--|
| Examiner<br>Signature |  | Date<br>Considered |  |
|-----------------------|--|--------------------|--|

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<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> Applicant is to place a check mark here if English language Translation is attached.

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